## REMARKS

Applicants have amended their specification on the first page thereof, to refer to the applications being relied upon under 35 USC §120 in the above-identified application, consistent with the requirements of 35 USC §120.

Applicants have further amended the specification of the above-identified application consistent with amendments made to the specification in prior application Serial No. 09/909,872.

It is respectfully submitted that these amendments to the specification do not add new matter to the application.

Attached hereto is a marked-up version of the changes made to original specification paragraphs, by the current Amendment. This marked-up version is on the attached pages, the first page of which is captioned "**VERSION WITH MARKINGS TO SHOW CHANGES MADE**".

To the extent necessary, Applicants petition for an extension of time under 37 CFR § 1.136. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account No.

01-2135 (Case No. 520.35833VV5) and please credit any excess fees to such Deposit Account.

Respectfully submitted,

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## ATTACHMENT A

## VERSION WITH MARKINGS TO SHOW CHANGES MADE

**In the Specification:**

Please amend the paragraph at page 6, lines 1-8, as indicated below:

Means for solving the above-specified problems will be described with reference to Fig. 2. Fig. 2 shows an [ordinary] experimental induction type plasma generating apparatus, used for verifying the present invention. With this apparatus, the methods for reducing the partial removal of the vacuum chamber wall around the plasma generating portion by the plasma and for improving the ignitability of the plasma are examined by changing the way of grounding the Faraday shield and the antenna to the earth.

Please amend the paragraph at page 28, lines 9-29, as indicated below:

Fig. 19 shows an eleventh embodiment of the invention. The basic apparatus construction of the present embodiment is identical to that of the eighth embodiment, but what is different from the other embodiments is that magnetic field generating means 16 is disposed outside the vacuum chamber 1. In Fig. 19, as well as in Fig. 20, reference character 11 is a connector for the interconnecting cable for the RF power supply. The plasma density distribution just above the

substrate in the presence of the magnetic field is illustrated in Fig. 25. From the graph showing the plasma density distribution, it is found that the plasma density is higher in the periphery as the magnetic field is increased. Thus, the magnetic field generating means acts as an auxiliary one capable of controlling the distribution.